

# High Resolution Wavelength Meter

*Based on the PIC version of a Mach-Zehnder interferometer (MZI)*



## Positive Impact

- Miniaturization and Stability
- Overcoming Environmental and System Noise
- Enabling New Levels of Precision and Resolution



## Initial Validation

This is a 19-inch industrial rack system with a technology readiness level of 6.



## Solution

This unique technology integrates an optical chip with advanced thermal and mechanical conditioning. This unique combination has set a world record for the most precise wavelength measurement ever recorded.



## Problem

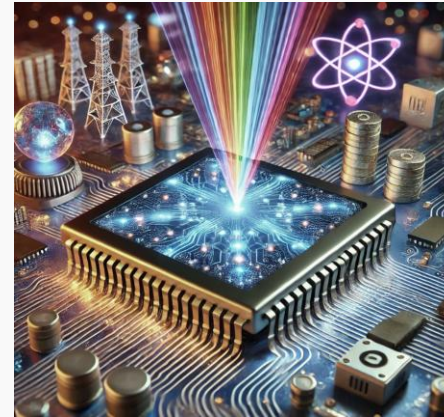
Current electronic and free-space optical systems are unable to achieve the required precision for next-generation applications in quantum physics, advanced metrology, and telecommunications. They are fundamentally limited by noise, drift, and crosstalk, which prevent them from reaching resolutions below a wavelength shift of 1 fm.



## Technology

→ The technology is based on integrated photonics chips combined with a scanning laser, low noise front-end electronics back-end electronics and algorithms to reach a resolution of 1fm ( $10^{-15}$ ) on a 1,55 micron ( $10^{-6}$ ) basic wavelength.

→ All components used are the industrial end subsystems.



For illustration purpose only



## Call to Action !!!

We are looking for individuals with entrepreneurial mindset and strong experience in optical system design and development. Interested?

Please reach out at:

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## Potential Markets

Several markets will be benefitted from this technology such as:

- Advanced Metrology and Industrial Inspection
- Quantum Technology and Sensing
- Spectroscopy and Chemical Analysis